

	Type	L #	Hits	Search Text	DBs	Time Stamp
1	IS&R	L1	47	(("6511924") or ("6764958") or ("6531398") or ("6797643") or ("6486061") or ("6635575") or ("6465372") or ("6573196") or ("6614181") or ("6566278") or ("6627532") or ("6531398") or ("6500773") or ("6472333") or ("6486082") or ("6759327") or ("6849562") or ("6699784") or ("6583497") or ("6838393") or ("6797643") or ("6858923") or ("6790788") or ("6806207")) .PN.	US- PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 11:53

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Inventor Name Search Result


for 10/773060

Your Search was:

Last Name = ZHENG


First Name = YI

Application#	Patent#	Status	Date Filed	Title	Inventor Name
<u>09853527</u>	6800774	150	05/10/2001	CATALYSTS USED FOR OLEFINE POLYMERIZATION AND THE PREPARATION THEREOF	ZHENG, YI
<u>09971277</u>	Not Issued	061	10/05/2001	NOVEL PHOTORESIST MATERIAL TO ACHIEVE HARDBAKE RESIST SHAPE CONTROL	ZHENG, YI
<u>10122481</u>	Not Issued	092	04/12/2002	METHOD FOR CLEANING A PROCESS CHAMBER	ZHENG, YI
<u>10124655</u>	6815373	150	04/16/2002	USE OF CYCLIC SILOXANES FOR HARDNESS IMPROVEMENT OF LOW K DIELECTRIC FILMS	ZHENG, YI
<u>10196498</u>	Not Issued	094	07/15/2002	METHOD OF DEPOSITING DIELECTRIC MATERIALS IN DAMASCENE APPLICATIONS	ZHENG, YI
<u>10266551</u>	Not Issued	030	10/07/2002	TWO-LAYER FILM FOR NEXT GENERATION DAMASCENE BARRIER APPLICATION WITH GOOD OXIDATION RESISTANCE	ZHENG, YI
<u>10302393</u>	Not Issued	094	11/22/2002	METHOD FOR FORMING ULTRA LOW K FILMS USING ELECTRON BEAM	ZHENG, YI
<u>10378783</u>	Not Issued	041	03/03/2003	MODULATED/COMPOSITED CVD LOW-K FILMS WITH IMPROVED MECHANICAL AND ELECTRICAL PROPERTIES FOR NANOELECTRONIC DEVICES	ZHENG, YI
<u>10409887</u>	Not Issued	083	04/08/2003	REACTING AN ORGANOSILICON COMPOUND WITH AN OXIDIZING GAS TO FORM AN ULTRA LOW K DIELECTRIC	ZHENG, YI
<u>10431492</u>	6813006	150	05/07/2003	STAND-ALONE SPEEDOMETER	ZHENG, YI



				DIRECTLY MEASURING THE TRANSLATIONAL SPEED BASED ON THE DIFFERENCE BETWEEN DISPERSIVE DRAGGING EFFECTS OF DIFFERENT MEDIA	
<u>10684150</u>	Not Issued	030	10/09/2003	ASYNCHRONOUS MODULATION AND DEMODULATION FOR SPREAD SPECTRUM AND CODE- DIVISION MULTIPLE ACCESS COMMUNICATION	ZHENG, YI
<u>10718281</u>	Not Issued	020	11/19/2003	COMPOSED EXCITATION PULSE USING ORTHOGONAL TONE BURSTS FOR DOPPLER COLOR FLOW MAPPING OF MEDICAL ULTRASOUND	ZHENG, YI
<u>10773060</u>	Not Issued	030	02/04/2004	ULTRA LOW DIELECTRIC MATERIALS BASED ON HYBRID SYSTEM OF LINEAR SILICON PRECURSOR AND ORGANIC POROGEN BY PLASMA- ENHANCED CHEMICAL VAPOR DEPOSITION (PECVD)	ZHENG, YI
<u>10792330</u>	Not Issued	030	03/02/2004	REACTIVE ION MILLING / RIE ASSISTED CMP	ZHENG, YI
<u>10857151</u>	Not Issued	030	05/28/2004	METHOD FOR ENHANCING WAFER ALIGNMENT MARKS	ZHENG, YI
<u>10875668</u>	Not Issued	071	06/23/2004	USE OF CYCLIC SILOXANES FOR HARDNESS IMPROVEMENT	ZHENG, YI
<u>10883327</u>	Not Issued	030	06/30/2004	MAGNETIC HEAD HAVING A DEPOSITED SECOND MAGNETIC SHIELD AND FABRICATION METHOD THEREFOR	ZHENG, YI
<u>10884368</u>	Not Issued	020	06/30/2004	METHOD AND APPARATUS FOR DEFINING LEADING EDGE TAPER OF A WRITE POLE TIP	ZHENG, YI
<u>10918328</u>	Not Issued	019	08/12/2004	MOBILIZATION OF HEMATOPOIETIC CELLS	ZHENG, YI
<u>10918648</u>	Not Issued	020	08/12/2004	CHIMERIC PEPTIDES FOR THE REGULATION OF GTPASES	ZHENG, YI
<u>10928466</u>	Not Issued	030	08/26/2004	METHODS AND SYSTEMS OF ENHANCING STEPPER ALIGNMENT SIGNALS AND METROLOGY ALIGNMENT TARGET SIGNALS	ZHENG, YI
<u>10943543</u>	Not Issued	030	09/18/2004	OPTICAL ACCELEROMETER USING GENERALIZED SAGNAC	ZHENG, YI

				EFFECT	
<u>10956461</u>	Not Issued	019	10/01/2004	DETECTION OF MOTION IN VIBRO-ACOUSTOGRAPHY	ZHENG, YI
<u>11035659</u>	Not Issued	020	01/14/2005	STAND-ALONE SPEEDOMETER USING TWO SPACED LASER BEAMS	ZHENG, YI
<u>11035660</u>	Not Issued	020	01/14/2005	RELATIVE MOTION SENSOR	ZHENG, YI
<u>60340615</u>	Not Issued	159	12/14/2001	METHOD OF DEPOSITING DIELECTRIC MATERIALS IN DAMASCENE APPLICATIONS	ZHENG, YI
<u>60413920</u>	Not Issued	159	09/25/2002	MULTI-CHANNEL MUSIC ENTERTAINMENT SYSTEM	ZHENG, YI
<u>60417513</u>	Not Issued	159	10/09/2002	ASYNCHRONOUS MODULATION AND DEMODULATION FOR SPREAD SPECTRUM AND CODE-DIVISION MULTIPLE ACCESS COMMUNICATION, DIRECT CELLULAR PHONE LINKS, AND FREE ACCESS WIRELESS COMMUNICATION SYSTEMS	ZHENG, YI
<u>60420124</u>	Not Issued	159	10/22/2002	MULTIPLE FREQUENCY EXCITATIONS FOR ULTRASONIC COLOR FLOW MAPPING	ZHENG, YI
<u>60454176</u>	Not Issued	159	03/12/2003	STAND-ALONE SPEEDOMETERS DIRECTLY MEASURING THE TRANSLATIONAL SPEED BASED ON THE CHANGE OF TRAVEL-TIME DIFFERENCE BETWEEN TWO ELECTROMAGNETIC WAVE BEAMS	ZHENG, YI
<u>60462482</u>	Not Issued	159	04/11/2003	WZYL EFFECT, THE FIBER OPTIC CONVEYOR AND A DETECTOR OF TRANSLATIONALLY RELATIVE MOTION	ZHENG, YI
<u>60474978</u>	Not Issued	159	06/02/2003	STAND-ALONE SPEEDOMETER DIRECTLY MEASURING THE TRANSLATIONAL SPEED BASED ON THE TRAVEL-TIME DIFFERENCE BETWEEN TWO ELECTROMAGNETIC WAVE BEAMS USING RESONATORS	ZHENG, YI
<u>60494718</u>	Not Issued	159	08/13/2003	MOBILIZATION OF HEMATOPOIETIC CELLS	ZHENG, YI
<u>60494719</u>	Not	159	08/13/2003	CHIMERIC PEPTIDES FOR THE	ZHENG, YI



	Issued			REGULATION OF GTPASES	
<u>60494943</u>	Not Issued	159	08/13/2003	STAND-ALONE SPEEDOMETER DIRECTLY MEASURING THE TRANSLATIONAL SPEED BASED ON THE FIRST-ORDER TRAVEL-TIME DIFFERENCE BETWEEN TWO SPACED LASER BEAMS EMITTED FROM THE SAME LASER	ZHENG, YI
<u>60504551</u>	Not Issued	159	09/18/2003	FIBER OPTIC ACCELEROMETER	ZHENG, YI
<u>60508371</u>	Not Issued	159	10/03/2003	MOTION DETECTION FOR VIBRO-ACOUSTOGRAPHY	ZHENG, YI
<u>60523599</u>	Not Issued	159	11/20/2003	GTPASE INHIBITORS AND METHODS OF USE	ZHENG, YI
<u>60536410</u>	Not Issued	159	01/14/2004	STAND-ALONE SPEEDOMETER USING TWO SPACED LASER BEAMS AND RELATIVE MOTION DETECTOR	ZHENG, YI
<u>60550530</u>	Not Issued	159	03/05/2004	TECHNIQUES FOR REDUCING THICKNESS OF LOW K FILMS DEPOSITED AT WAFER EDGE	ZHENG, YI
<u>60558366</u>	Not Issued	020	03/31/2004	MULTI-STAGE CURING OF LOW K NANO-POROUS FILMS	ZHENG, YI
<u>60629380</u>	Not Issued	020	11/19/2004	GTPASE INHIBITORS AND USE THEREOF FOR CONTROLLING PLATELET HYPERREACTIVITY	ZHENG, YI
<u>09978324</u>	Not Issued	161	10/16/2001	FAMILY OF CANADENSOL TAXANES, THE SEMI-SYNTHETIC PREPARATION AND THERAPEUTIC USE THEREOF	ZHENG, YI FENG
<u>10736004</u>	Not Issued	020	12/15/2003	ASSAY FOR ENTACTOGENS	ZHENG, YI FENG
<u>10736005</u>	Not Issued	030	12/15/2003	ASSAY FOR ENTACTOGENS	ZHENG, YI FENG
<u>10736018</u>	Not Issued	030	12/15/2003	ECSTASY HAPTENS AND IMMUNOGENS	ZHENG, YI FENG
<u>10805813</u>	Not Issued	030	03/22/2004	ASSAYS FOR AMPHETAMINE AND METHAMPHETAMINE USING STEREOSPECIFIC REAGENTS	ZHENG, YI FENG
<u>10806327</u>	Not Issued	030	03/22/2004	ASSAYS FOR AMPHETAMINE AND METHAMPHETAMINE	ZHENG, YI FENG
<u>08957138</u>	<u>6410756</u>	150	10/24/1997	FAMILY OF CANADENSOL TAXANES, THE SEMI-	ZHENG, YI FENG

				SYNTHETIC PREPARATION AND THERAPEUTIC USE THEREOF	
<u>10818115</u>	Not Issued	030	04/05/2004	IMMUNOASSAYS FOR BUPRENORPHINE AND NORBUPRENORPHINE	ZHENG, YI- FENG

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Last Name = ZHENG

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Application#	Patent#	Status	Date Filed	Title	Inventor Name
<u>09193932</u>	<u>6201887</u>	150	11/17/1998	SYSTEM FOR DETERMINATION OF FAULTY CIRCUIT BOARDS IN ULTRASOUND IMAGING MACHINES	ZHENG, YIBIN
<u>09316011</u>	<u>6370480</u>	150	05/21/1999	QUANTITATIVE ANALYSIS SYSTEM AND METHOD FOR CERTIFYING ULTRASOUND MEDICAL IMAGING EQUIPMENT	ZHENG, YIBIN
<u>09607004</u>	<u>6404379</u>	150	06/29/2000	MATRIX MONOPULSE RATIO RADAR PROCESSOR FOR TWO TARGET AZIMUTH AND ELEVATION ANGLE DETERMINATION	ZHENG, YIBIN
<u>09607146</u>	<u>6356231</u>	150	06/29/2000	MONOPULSE RADAR PROCESSOR FOR RESOLVING TWO SOURCES	ZHENG, YIBIN
<u>10026985</u>	<u>6678551</u>	150	12/27/2001	METHOD AND APPARATUS FOR NOISE REDUCTION OF ELECTROMYOGRAM SIGNALS	ZHENG, YIBIN
<u>10045706</u>	Not Issued	092	01/15/2002	METHOD AND APPARATUS FOR UTERINE CONTRACTION MONITORING USING LINEAR PREDICTIVE MODELING OF ABDOMINAL SURFACE EMG SIGNALS	ZHENG, YIBIN
<u>60584208</u>	Not Issued	020	06/30/2004	METHOD AND APPARATUS FOR INCREASING THE DEPTH OF FOCUS IN MEDICAL ULTRASOUND USING A SINC TRANSMIC APERTURE	ZHENG, YIBIN
<u>07618410</u>	<u>5119296</u>	150	11/27/1990	METHOD AND APPARATUS FOR INPUTTING RADICAL-ENCODED CHINESE	ZHENG, YILI

				CHARACTERS	
<u>10133695</u>	Not Issued	030	04/25/2002	SYSTEM AND METHOD FOR OPTIMIZED DESIGN OF AN OPTICAL NETWORK	ZHENG, YINDONG
<u>60287030</u>	Not Issued	159	04/26/2001	LIGHT-PATH AWARE DWDM NETWORK COST OPTIMIZATION METHODOLOGY	ZHENG, YINDONG
<u>06907664</u>	4784983	150	09/15/1986	CATALYST SYSTEM FOR USE IN OLEFINIC POLYMERIZATION	ZHENG, YING
<u>07211459</u>	4861847	150	06/24/1988	CATALYST SYSTEM FOR USE IN OLEFINIC POLYMERIZATION	ZHENG, YING
<u>09018566</u>	6093436	150	02/04/1998	BEVERAGE ANTIOXIDANT SYSTEM	ZHENG, YING
<u>09453932</u>	6319537	150	05/16/2000	STABLE COFFEE CONCENTRATE SYSTEM	ZHENG, YING
<u>09676453</u>	6716344	150	10/02/2000	LIQUID-SOLIDS CIRCULATING FLUIDIZED BED	ZHENG, YING
<u>10450555</u>	Not Issued	041	11/17/2003	CATALYST COMPONENT FOR POLYMERIZATION OF OLEFINS, CATALYST CONTAINING THE COMPONENT AND USE OF THE SAME	ZHENG, YING
<u>10472542</u>	Not Issued	020	06/07/2004	SEX- SPECIFIC SELECTION OF SPERM FROM TRANSGENIC ANIMALS	ZHENG, YING
<u>10661388</u>	Not Issued	080	09/11/2003	STABILIZATION OF AROMA-PROVIDING COMPONENTS	ZHENG, YING
<u>10661397</u>	Not Issued	080	09/11/2003	STABILIZED AROMA-PROVIDING COMPONENTS AND FOODSTUFFS CONTAINING SAME	ZHENG, YING
<u>10661432</u>	Not Issued	080	09/11/2003	AROMA-CONTAINING COMPONENTS	ZHENG, YING
<u>10670239</u>	Not Issued	041	09/26/2003	STABILIZER-FREE STABILIZED COFFEE AROMA	ZHENG, YING
<u>10778593</u>	Not Issued	092	02/17/2004	METHOD FOR RECOVERING IONIC PRODUCTS	ZHENG, YING
<u>10804643</u>	Not Issued	020	03/19/2004	HAIR FOLLICLE FORMATION FROM ADULT DERMAL CELLS	ZHENG, YING
<u>10978279</u>	Not Issued	019	10/28/2004	SYSTEM, METHOD AND COMPOSITIONS FOR DISPENSING A LIQUID	ZHENG, YING

				BEVERAGE CONCENTRATE	
<u>60134640</u>	Not Issued	159	05/18/1999	STABLE COFFEE CONCENTRATE SYSTEM	ZHENG, YING
<u>60278155</u>	Not Issued	159	03/22/2001	SEX-SPECIFIC SELECTION OF SPERM FROM TRANSGENIC ANIMALS	ZHENG, YING
<u>60278506</u>	Not Issued	159	03/23/2001	STABILIZATION OF COFFEE AROMA	ZHENG, YING
<u>60295644</u>	Not Issued	159	06/04/2001	METHODS AND COMPOSITIONS FOR REGULATING CYSTATIN A	ZHENG, YING
<u>60601496</u>	Not Issued	020	08/13/2004	ORGANOGENESIS FROM DISSOCIATED CELLS: GENERATION OF MATURE CYCLING HAIR FOLLICLES FROM SKIN DERIVED CELLS	ZHENG, YING
<u>10204029</u>	Not Issued	030	08/15/2002	DNA MOLECULES ENCODING LIGAND-GATED ION CHANNELS FROM DROSOPHILA MELANOGASTER	ZHENG, YINGCONG
<u>10239420</u>	Not Issued	071	09/23/2002	DNA MOLECULES ENCODING LIGAND GATED ION CHANNELS FROM DERMACENTOR VARIABILIS	ZHENG, YINGCONG
<u>10239956</u>	Not Issued	030	09/25/2002	DERMACENTOR VARIABILIS GABA-GATED CHLORIDE CHANNELS	ZHENG, YINGCONG
<u>60193791</u>	Not Issued	159	03/31/2000	DERMACENTOR VARIABILIS GABA-GATED CHLORIDE CHANNELS	ZHENG, YINGCONG
<u>60193935</u>	Not Issued	159	03/31/2000	DNA MOLECULES ENCODING LIGAND GATED ION CHANNELS FROM DERMACENTOR VARIABLES	ZHENG, YINGCONG
<u>60615431</u>	Not Issued	020	10/01/2004	SCREW SLEEVE MADE OF (PEEK) POLYETHERETHERKETONE FOR AUGMENTATION OF PEDICLE SCREW INSERTION IN OSTEOPOROTIC OR REVISION LUMBAR SPINE INSTRUMENTATION	ZHENG, YINGGANG
<u>10454870</u>	Not Issued	092	06/06/2003	SEMICONDUCTOR POWER DEVICE HAVING A DIAMOND SHAPED METAL	ZHENG, YINGPING

				INTERCONNECT SCHEME	
10752772	Not Issued	041	01/08/2004	METHOD OF FORMING AN EPROM CELL AND STRUCTURE THEREFOR	ZHENG, YINGPING
60620494	Not Issued	020	10/20/2004	INVERTIBLE DATA HIDING BASED ON INTEGER WAVELET TRANSFORM AND COMPANDING TECHNIQUE	ZHENG, YIZHAN
60397060	Not Issued	159	07/18/2002	REMOVAL OF CONSTITUENTS FROM TOBACCO	ZHENG, YIZHOU
10664675	Not Issued	041	09/18/2003	ELECTROLUMINESCENCE (EL) TUBE AND WIRE AND MANUFACTURING METHOD	ZHENGKAI, YIN

Inventor Search Completed: No Records to Display.

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Inventor Name Search Result

Your Search was:

Last Name = NEMANI

First Name = SRINIVAS

Application#	Patent#	Status	Date Filed	Title	Inventor Name
<u>08746631</u>	6114216	150	11/13/1996	METHODS FOR SHALLOW TRENCH ISOLATION	NEMANI, SRINIVAS
<u>08747892</u>	5935340	150	11/13/1996	METHODS AND APPARATUS FOR GETTERING FLUORINE FROM CHAMBER MATERIAL SURFACES	NEMANI, SRINIVAS
<u>08748095</u>	5812403	150	11/13/1996	METHODS AND APPARATUS FOR CLEANING SURFACES IN A SUBSTRATE PROCESSING SYSTEM	NEMANI, SRINIVAS
<u>08748883</u>	Not Issued	161	11/13/1996	SYSTEMS AND METHODS FOR HIGH TEMPERATURE PROCESSING OF SEMICONDUCTOR WAFERS	NEMANI, SRINIVAS
<u>08748960</u>	5963840	150	11/13/1996	METHODS FOR DEPOSITING PREMETAL DIELECTRIC LAYER AT SUB-ATMOSPHERIC AND HIGH TEMPERATURE CONDITIONS	NEMANI, SRINIVAS
<u>08954299</u>	6090206	150	10/20/1997	THROTTLE VALVE PROVIDING ENHANCED CLEANING	NEMANI, SRINIVAS
<u>09334437</u>	6348099	150	06/16/1999	METHODS AND APPARATUS FOR DEPOSITING PREMETAL DIELECTRIC LAYER AT SUB-ATMOSPHERIC AND HIGH TEMPERATURE CONDITIONS	NEMANI, SRINIVAS
<u>09338470</u>	6413583	150	06/22/1999	FORMATION OF A LIQUID-LIKE SILICA LAYER BY REACTION OF AN ORGANOSILICON COMPOUND AND A	NEMANI, SRINIVAS

				HYDROXYL FORMING COMPOUND	
<u>09340602</u>	<u>6347636</u>	150	06/25/1999	METHODS AND APPARATUS FOR GETTERING FLUORINE FROM CHAMBER MATERIAL SURFACES	NEMANI, SRINIVAS
<u>09613934</u>	<u>6352591</u>	150	07/11/2000	METHODS AND APPARATUS FOR SHALLOW TRENCH ISOLATION	NEMANI, SRINIVAS
<u>09633078</u>	Not Issued	161	08/04/2000	METHOD AND APPARATUS FOR REMOVING SILICON CARBIDE FROM SEMICONDUCTOR SUBSTRATES	NEMANI, SRINIVAS
<u>09660268</u>	<u>6465366</u>	150	09/12/2000	DUAL FREQUENCY PLASMA ENHANCED CHEMICAL VAPOR DEPOSITION OF SILICON CARBIDE LAYERS	NEMANI, SRINIVAS
<u>09793818</u>	<u>6537733</u>	150	02/23/2001 110 D	METHOD OF DEPOSITING LOW DIELECTRIC CONSTANT SILICON CARBIDE LAYERS	NEMANI, SRINIVAS
<u>09820463</u>	Not Issued	083	03/28/2001	PLASMA TREATMENT OF ORGANOSILICATE LAYERS	NEMANI, SRINIVAS
<u>09839337</u>	<u>6511924</u>	150	04/20/2001	METHOD OF FORMING A SILICON OXIDE LAYER ON A SUBSTRATE	NEMANI, SRINIVAS
<u>10238195</u>	<u>6589888</u>	150	09/09/2002 A	DUAL FREQUENCY PLASMA ENHANCED CHEMICAL VAPOR DEPOSITION OF SILICON CARBIDE LAYERS	NEMANI, SRINIVAS
<u>10375793</u>	Not Issued	030	02/25/2003	METHOD OF DEPOSITING LOW DIELECTRIC CONSTANT SILICON CARBIDE LAYERS	NEMANI, SRINIVAS
<u>10375853</u>	<u>6855484</u>	150	02/25/2003	METHOD OF DEPOSITING LOW DIELECTRIC CONSTANT SILICON CARBIDE LAYERS	NEMANI, SRINIVAS
<u>10858135</u>	Not Issued	030	06/01/2004	DIELECTRIC GAP FILL WITH OXIDE SELECTIVELY DEPOSITED OVER SILICON LINER	NEMANI, SRINIVAS
<u>60340615</u>	Not Issued	159	12/14/2001	METHOD OF DEPOSITING DIELECTRIC MATERIALS IN DAMASCENE APPLICATIONS	NEMANI, SRINIVAS
<u>09557079</u>	<u>6596343</u>	150	04/21/2000	METHOD FOR PROCESSING SEMICONDUCTOR	NEMANI, SRINIVAS D.

				SUBSTRATES WITH HYDROXYL RADICALS	
<u>09627667</u>	<u>6764958</u>	150	07/28/2000	METHOD OF DEPOSITING DIELECTRIC FILMS	NEMANI, SRINIVAS D.
<u>09702600</u>	<u>6531398</u>	150	10/30/2000	METHOD OF DEPOSITING ORGANOSILICATE LAYERS	NEMANI, SRINIVAS D.
<u>09908668</u>	Not Issued	061	07/18/2001	PROCESS AND APPARATUS FOR ABATEMENT OF BY PRODUCTS GENERATED FROM DEPOSITION PROCESSES AND CLEANING OF DEPOSITION CHAMBERS	NEMANI, SRINIVAS D.
<u>10122481</u>	Not Issued	092	04/12/2002	METHOD FOR CLEANING A PROCESS CHAMBER	NEMANI, SRINIVAS D.
<u>10124655</u>	<u>6815373</u>	150	04/16/2002	USE OF CYCLIC SILOXANES FOR HARDNESS IMPROVEMENT OF LOW K DIELECTRIC FILMS	NEMANI, SRINIVAS D.
<u>10196498</u>	Not Issued	094	07/15/2002	METHOD OF DEPOSITING DIELECTRIC MATERIALS IN DAMASCENE APPLICATIONS	NEMANI, SRINIVAS D.
<u>10266551</u>	Not Issued	030	10/07/2002	TWO-LAYER FILM FOR NEXT GENERATION DAMASCENE BARRIER APPLICATION WITH GOOD OXIDATION RESISTANCE	NEMANI, SRINIVAS D.
<u>10279367</u>	<u>6797643</u>	150	10/23/2002	PLASMA ENHANCED CVD LOW K CARBON DOPED SILICON OXIDE FILM DEPOSITION USING VHF-RF POWER	NEMANI, SRINIVAS D.
<u>10293543</u>	Not Issued	095	11/12/2002	SIDE WALL PASSIVATION FILMS FOR DAMASCENE CU/LOW K ELECTRONIC DEVICES	NEMANI, SRINIVAS D.
<u>10302393</u>	Not Issued	094	11/22/2002	METHOD FOR FORMING ULTRA LOW K FILMS USING ELECTRON BEAM	NEMANI, SRINIVAS D.
<u>10355379</u>	Not Issued	094	01/31/2003	METHOD FOR DEPOSITING A LOW DIELECTRIC CONSTANT FILM	NEMANI, SRINIVAS D.
<u>10409887</u>	Not Issued	083	04/08/2003	REACTING AN ORGANOSILICON COMPOUND WITH AN OXIDIZING GAS TO FORM AN	NEMANI, SRINIVAS D.

				ULTRA LOW K DIELECTRIC	
<u>10453227</u>	Not Issued	071	06/02/2003	METHOD AND APPARATUS FOR PROCESSING SEMICONDUCTOR SUBSTRATES WITH HYDROXYL RADICALS	NEMANI, SRINIVAS D.
<u>10773060</u>	Not Issued	030	02/04/2004	ULTRA LOW DIELECTRIC MATERIALS BASED ON HYBRID SYSTEM OF LINEAR SILICON PRECURSOR AND ORGANIC POROGEN BY PLASMA-ENHANCED CHEMICAL VAPOR DEPOSITION (PECVD)	NEMANI, SRINIVAS D.
<u>10875668</u>	Not Issued	071	06/23/2004	USE OF CYCLIC SILOXANES FOR HARDNESS IMPROVEMENT ✓	NEMANI, SRINIVAS D.
<u>10894872</u>	Not Issued	030	07/20/2004 NO O	METHOD OF DEPOSITING DIELECTRIC FILMS SiC	NEMANI, SRINIVAS D.
<u>10931742</u>	Not Issued	041	09/01/2004	SILICON OXIDE GAPFILL DEPOSITION USING LIQUID PRECURSORS	NEMANI, SRINIVAS D.

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Last Name = XIA

First Name = LI-QUN

Application#	Patent#	Status	Date Filed	Title	Inventor Name
08627631	6599574	150	04/04/1996	METHOD AND APPARATUS FOR FORMING A DIELECTRIC FILM USING HELIUM AS A CARRIER GAS	XIA, LI-QUN
08709436	5862057	150	09/06/1996	METHOD AND APPARATUS FOR TUNING A PROCESS RECIPE TO TARGET DOPANT CONCENTRATIONS IN A DOPED LAYER	XIA, LI-QUN
08746631	6114216	150	11/13/1996	METHODS FOR SHALLOW TRENCH ISOLATION	XIA, LI-QUN
08747892	5935340	150	11/13/1996	METHODS AND APPARATUS FOR GETTERING FLUORINE FROM CHAMBER MATERIAL SURFACES	XIA, LI-QUN
08748094	5994209	150	11/13/1996	METHODS AND APPARATUS FOR FORMING ULTRA-SHALLOW DOPED REGIONS USING DOPED SILICON OXIDE FILMS	XIA, LI-QUN
08748095	5812403	150	11/13/1996	METHODS AND APPARATUS FOR CLEANING SURFACES IN A SUBSTRATE PROCESSING SYSTEM	XIA, LI-QUN
08748883	Not Issued	161	11/13/1996	SYSTEMS AND METHODS FOR HIGH TEMPERATURE PROCESSING OF SEMICONDUCTOR WAFERS	XIA, LI-QUN
08748960	5963840	150	11/13/1996	METHODS FOR DEPOSITING PREMETAL DIELECTRIC LAYER AT SUB-ATMOSPHERIC AND HIGH TEMPERATURE CONDITIONS	XIA, LI-QUN
09075561	6360685	150	05/05/1998	SUB-ATMOSPHERIC CHEMICAL VAPOR DEPOSITION SYSTEM WITH DOPANT BYPASS	XIA, LI-QUN
09076170	6218268	150	05/05/1998	TWO-STEP BOROPHOSPHOSILICATE GLASS DEPOSITION PROCESS AND	XIA, LI-QUN

				RELATED DEVICES AND APPARATUS	
<u>09163864</u>	Not Issued	161	09/30/1998	METHOD AND APPARATUS FOR REDUCING ETCH UNDERCUT	XIA, LI-QUN
<u>09199911</u>	6177344	150	11/25/1998	BPSG REFLOW METHOD TO REDUCE THERMAL BUDGET FOR NEXT GENERATION DEVICE INCLUDING HEATINGT A STEAM AMBIENT	XIA, LI-QUN
<u>09251701</u>	Not Issued	161	02/17/1999	METHOD AND APPARATUS FOR FORMING MATERIAL LAYERS FROM ATOMIC GASSES	XIA, LI-QUN
<u>09262782</u>	6261975	150	03/04/1999	METHOD FOR DEPOSITING AND PLANARIZING FLUORINATED BPSG FILMS	XIA, LI-QUN
<u>09322709</u>	6153261	150	05/28/1999	DIELECTRIC FILM DEPOSITION EMPLOYING A BISTERTIARYBUTYLAMINESILANE PRECURSOR	XIA, LI-QUN
<u>09334437</u>	6348099	150	06/16/1999	METHODS AND APPARATUS FOR DEPOSITING PREMETAL DIELECTRIC LAYER AT SUB-ATMOSPHERIC AND HIGH TEMPERATURE CONDITIONS	XIA, LI-QUN
<u>09338470</u>	6413583	150	06/22/1999	FORMATION OF A LIQUID-LIKE SILICA LAYER BY REACTION OF AN ORGANOSILICON COMPOUND AND A HYDROXYL FORMING COMPOUND	XIA, LI-QUN
<u>09340602</u>	6347636	150	06/25/1999	METHODS AND APPARATUS FOR GETTERING FLUORINE FROM CHAMBER MATERIAL SURFACES	XIA, LI-QUN
<u>09379834</u>	6255222	150	08/24/1999	METHOD FOR REMOVING RESIDUE FROM SUBSTRATE PROCESSING CHAMBER EXHAUST LINE FOR SILICON-OXYGEN-CARBON DEPOSITION PROCESS	XIA, LI-QUN
<u>09400338</u>	6503843	150	09/21/1999	A MULTISTEP CHAMBER CLEANING AND FILM DEPOSITION PROCESS USING A REMOTE PLASMA THAT ALSO ENHANCES FILM GAP FILL	XIA, LI-QUN
<u>09409763</u>	6099647	150	09/30/1999	METHODS AND APPARATUS FOR FORMING ULTRA-SHALLOW DOPED REGIONS USING DOPED SILICON OXIDE FILMS	XIA, LI-QUN
<u>09461504</u>	6426015	150	12/14/1999	METHOD OF REDUCING	XIA, LI-

				UNDESIRE ETCHING OF INSULATION DUE TO ELEVATED BORON CONCENTRATIONS	QUN
<u>09557079</u>	<u>6596343</u>	150	04/21/2000	METHOD FOR PROCESSING SEMICONDUCTOR SUBSTRATES WITH HYDROXYL RADICALS	XIA, LI-QUN
<u>09613934</u>	<u>6352591</u>	150	07/11/2000	METHODS AND APPARATUS FOR SHALLOW TRENCH ISOLATION	XIA, LI-QUN
<u>09625911</u>	Not Issued	168	07/26/2000	THERMAL CVD PROCESS FOR DEPOSITING A LOW DIELECTRIC CONSTANT CARBON-DOPED SILICON OXIDE FILM	XIA, LI-QUN
<u>09627667</u>	<u>6764958</u>	150	07/28/2000	METHOD OF DEPOSITING DIELECTRIC FILMS	XIA, LI-QUN
<u>09632668</u>	<u>6602806</u>	150	08/07/2000	THERMAL CVD PROCESS FOR DEPOSITING A LOW DIELECTRIC CONTANT CARBON-DOPED SILICON OXIDE FILM	XIA, LI-QUN
<u>09632669</u>	<u>6486061</u>	150	08/07/2000	POST-DEPOSITION TREATMENT TO ENHANCE PROPERTIES OF SI-O-C LOW K FILMS	XIA, LI-QUN
<u>09633196</u>	<u>6635575</u>	150	08/07/2000	METHODS AND APPARATUS TO ENHANCE PROPERTIES OF SI-O-C LOW K FILMS	XIA, LI-QUN
<u>09633495</u>	<u>6465372</u>	150	08/07/2000	SURFACE TREATMENT OF C-DOPED SIO2 FILM TO ENHANCE FILM STABILITY DURING O2 ASHING	XIA, LI-QUN
<u>09633798</u>	<u>6528116</u>	150	08/07/2000	LID COOLING MECHANISM AND METHOD FOR OPTIMIZED DEPOSITION OF LOW-K DIELECTRIC USING TRI METHYLSILANE-OZONE BASED PROCESSES	XIA, LI-QUN
<u>09638803</u>	<u>6573196</u>	150	08/12/2000	METHOD OF DEPOSITING ORGANOSILICATE LAYERS	XIA, LI-QUN
<u>09644938</u>	<u>6614181</u>	150	08/23/2000	UV RADIATION SOURCE FOR DENSIFICATION OF CVD CARBON-DOPED SILICON OXIDE FILMS	XIA, LI-QUN
<u>09648289</u>	<u>6566278</u>	150	08/24/2000	METHOD FOR DENSIFICATION OF CVD CARBON-DOPED SILICON OXIDE FILMS THROUGH UV IRRADIATION	XIA, LI-QUN
<u>09657392</u>	Not Issued	161	09/08/2000	DUAL PLASMA TREATMENT OF SILICON CARBIDE FILMS	XIA, LI-QUN
<u>09660268</u>	<u>6465366</u>	150	09/12/2000	DUAL FREQUENCY PLASMA ENHANCED CHEMICAL VAPOR	XIA, LI-QUN

				DEPOSITION OF SILICON CARBIDE LAYERS	
<u>09679843</u>	<u>6627532</u>	150	10/05/2000	METHOD OF DECREASING THE K VALUE IN SIOC LAYER DEPOSITED BY CHEMICAL VAPOR DEPOSITION	XIA, LI-QUN
<u>09680562</u>	<u>6258735</u>	150	10/05/2000	METHOD FOR USING BYPASS LINES TO STABILIZE GAS FLOW AND MAINTAIN PLASMA INSIDE A DEPOSITION CHAMBER	XIA, LI-QUN
<u>09702600</u>	<u>6531398</u>	150	10/30/2000	METHOD OF DEPOSITING ORGANOSILICATE LAYERS	XIA, LI-QUN
<u>09706298</u>	<u>6753258</u>	150	11/03/2000	NOVEL INTEGRATION SCHEME FOR DUAL DAMASCENE STRUCTURE	XIA, LI-QUN
<u>09710357</u>	<u>6569257</u>	150	11/09/2000	METHOD FOR CLEANING A PROCESS CHAMBER	XIA, LI-QUN
<u>09723886</u>	<u>6500773</u>	150	11/27/2000	METHOD OF DEPOSITING ORGANOSILICATE LAYERS	XIA, LI-QUN
<u>09728718</u>	<u>6277200</u>	150	11/30/2000	DIELECTRIC FILM DEPOSITION EMPLOYING A BISTERTIARYBUTYLAMINESILANE PRECURSOR	XIA, LI-QUN
<u>09775010</u>	<u>6514850</u>	150	01/31/2001	INTERFACE WITH DIELECTRIC LAYER AND METHOD OF MAKING	XIA, LI-QUN
<u>09791989</u>	<u>6632478</u>	150	02/22/2001	METHODS FOR FORMING A LOW DIELECTRIC CONSTANT CARBON-CONTAINING FILM, AND FILMS PRODUCED THEREBY	XIA, LI-QUN
<u>09820439</u>	<u>6472333</u>	150	03/28/2001	SILICON CARBIDE CAP LAYERS FOR LOW DIELECTRIC CONSTANT SILICON OXIDE LAYERS	XIA, LI-QUN
<u>09820463</u>	Not Issued	083	03/28/2001	PLASMA TREATMENT OF ORGANOSILICATE LAYERS	XIA, LI-QUN
<u>09832756</u>	Not Issued	161	04/10/2001	TWO-STEP FLOURINATED-BOROPHOSOPHOSILICATE GLASS DEPOSITION PROCESS	XIA, LI-QUN
<u>09839869</u>	<u>6777171</u>	150	04/20/2001	FLUORINE-CONTAINING LAYERS FOR DAMASCENE STRUCTURES	XIA, LI-QUN
<u>09882111</u>	<u>6511920</u>	150	06/14/2001	OPTICAL MARKER LAYER FOR ETCH ENDPOINT DETERMINATION	XIA, LI-QUN

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Inventor Name Search Result

Your Search was:

Last Name = XIA

First Name = LI-QUN

Application#	Patent#	Status	Date Filed	Title	Inventor Name
<u>09885985</u>	<u>6486082</u>	150	06/18/2001	CVD PLASMA ASSISTED LOWER DIELECTRIC CONSTANT SICOH FILM	XIA, LI-QUN
<u>09912103</u>	Not Issued	083	07/23/2001	SELECTIVE ETCHING OF ORGANOSILICATE FILMS OVER SILICON OXIDE STOP ETCH LAYERS	XIA, LI-QUN
<u>09977008</u>	<u>6656837</u>	150	10/11/2001	METHOD OF ELIMINATING PHOTORESIST POISONING IN DAMASCENE APPLICATIONS	XIA, LI-QUN
<u>10006563</u>	<u>6680164</u>	150	11/30/2001	SOLVENT FREE PHOTORESIST STRIP AND RESIDUE REMOVAL PROCESSING FOR POST ETCHING OF LOW-K FILMS	XIA, LI-QUN
<u>10010950</u>	<u>6759327</u>	150	11/13/2001	METHOD OF DEPOSITING LOW K BARRIER LAYERS	XIA, LI-QUN
<u>10092203</u>	<u>6849562</u>	150	03/04/2002	METHOD OF DEPOSITING A LOW K DIELECTRIC BARRIER FILM FOR COPPER DAMASCENE APPLICATION	XIA, LI-QUN
<u>10096503</u>	<u>6699784</u>	150	03/12/2002	METHOD FOR DEPOSITING A LOW K DIELECTRIC FILM (K<3.5) FOR HARD MASK APPLICATION	XIA, LI-QUN
<u>10122106</u>	Not Issued	083	04/11/2002	METHODS FOR DEPOSITING DIELECTRIC MATERIAL	XIA, LI-QUN
<u>10124655</u>	<u>6815373</u>	150	04/16/2002	USE OF CYCLIC SILOXANES FOR HARDNESS IMPROVEMENT OF LOW K DIELECTRIC FILMS	XIA, LI-QUN
<u>10131317</u>	Not Issued	161	04/24/2002	METHOD AND APPARATUS FOR FORMING MATERIAL	XIA, LI-QUN

				LAYERS FROM ATOMIC GASSES	
<u>10192274</u>	<u>6583497</u>	150	07/09/2002	SURFACE TREATMENT OF C-DOPED <u>SiO₂</u> FILM TO ENHANCE FILM STABILITY DURING O ₂ ASHING	XIA, LI-QUN
<u>10196498</u>	Not Issued	094	07/15/2002	METHOD OF DEPOSITING DIELECTRIC MATERIALS IN DAMASCENE APPLICATIONS	XIA, LI-QUN
<u>10236800</u>	<u>6750141</u>	150	09/06/2002	SILICON CARBIDE CAP LAYERS FOR LOW DIELECTRIC CONSTANT SILICON OXIDE LAYERS	XIA, LI-QUN
<u>10238195</u>	<u>6589888</u>	150	09/09/2002	DUAL FREQUENCY PLASMA ENHANCED CHEMICAL VAPOR DEPOSITION OF SILICON CARBIDE LAYERS	XIA, LI-QUN
<u>10247404</u>	<u>6838393</u>	150	09/19/2002	LOW DIELECTRIC (LOW K) BARRIER FILMS WITH OXYGEN DOPING BY PLASMA-ENHANCED CHEMICAL VAPOR DEPOSITION (PECVD)	XIA, LI-QUN
<u>10266551</u>	Not Issued	030	10/07/2002	TWO-LAYER FILM FOR NEXT GENERATION DAMASCENE BARRIER APPLICATION WITH GOOD OXIDATION RESISTANCE	XIA, LI-QUN
<u>10279367</u>	<u>6797643</u>	150	10/23/2002	PLASMA ENHANCED CVD LOW K CARBON-DOPED SILICON OXIDE FILM DEPOSITION USING VHF-RF POWER	XIA, LI-QUN
<u>10291296</u>	Not Issued	094	11/08/2002	LID COOLING MECHANISM AND METHOD FOR OPTIMIZED DEPOSITION OF LOW-K DIELECTRIC USING TRI METHYLSILANE-OZONE BASED PROCESSES	XIA, LI-QUN
<u>10293096</u>	<u>6858923</u>	150	11/12/2002	POST-DEPOSITION TREATMENT TO ENHANCE PROPERTIES OF SI-O-C LOW FILMS	XIA, LI-QUN
<u>10293543</u>	Not Issued	095	11/12/2002	SIDE WALL PASSIVATION FILMS FOR DAMASCENE CU/LOW K ELECTRONIC DEVICES	XIA, LI-QUN

10302240	Not Issued Allow	094	11/22/2002	CVD PLASMA ASSISTED LOWER DIELECTRIC CONSTANT SICOH FILM	XIA, LI-QUN
10302375	Not Issued	040	11/22/2002	METHOD FOR CURING LOW DIELECTRIC CONSTANT FILM BY ELECTRON BEAM	XIA, LI-QUN
10302393	Not Issued	094	11/22/2002	METHOD FOR FORMING ULTRA LOW K FILMS USING ELECTRON BEAM	XIA, LI-QUN
10342077	Not Issued	093	01/13/2003	METHOD FOR CURING LOW DIELECTRIC CONSTANT FILM USING DIRECT CURRENT BIAS	XIA, LI-QUN
10342079	6790788	150	01/13/2003	METHOD OF IMPROVING STABILITY IN LOW K BARRIER LAYERS	XIA, LI-QUN
10342085	Not Issued	161	01/13/2003	METHOD AND APPARATUS TO IMPROVE CRACKING THRESHOLDS AND MECHANICAL PROPERTIES OF LOW-K DIELECTRIC MATERIAL	XIA, LI-QUN
10375852	6806207	150	02/25/2003	METHOD OF DEPOSITING LOW K FILMS	XIA, LI-QUN
10383837	Not Issued	092	03/07/2003	METHOD OF IMPROVING INTERLAYER ADHESION	XIA, LI-QUN
10387160	Not Issued Allow	093	03/11/2003	METHOD FOR MODIFYING DIELECTRIC CHARACTERISTICS OF DIELECTRIC LAYERS	XIA, LI-QUN
10409887	Not Issued	083	04/08/2003	REACTING AN ORGANOSILICON COMPOUND WITH AN OXIDIZING GAS TO FORM AN ULTRA LOW K DIELECTRIC	XIA, LI-QUN
10428374	Not Issued Appeal	121	05/01/2003	METHODS AND APPARATUS FOR E-BEAM TREATMENT USED TO FABRICATE INTEGRATED CIRCUIT DEVICES	XIA, LI-QUN
10453227	Not Issued	071	06/02/2003	METHOD AND APPARATUS FOR PROCESSING SEMICONDUCTOR SUBSTRATES WITH HYDROXYL RADICALS	XIA, LI-QUN
10632179	6784119	150	07/31/2003	METHOD OF DECREASING	XIA, LI-QUN

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Inventor Name Search Result

Your Search was:

Last Name = YIM

First Name = KANG

Application#	Patent#	Status	Date Filed	Title	Inventor Name
10140324	Not Issued	133	05/06/2002	METHOD AND APPARATUS FOR DEPOSITION OF LOW DIELECTRIC CONSTANT MATERIALS	YIM, KANG SUB
10247404	6838393	150	09/19/2002	LOW DIELECTRIC (LOW K) BARRIER FILMS WITH OXYGEN DOPING BY PLASMA-ENHANCED CHEMICAL VAPOR DEPOSITION (PECVD)	YIM, KANG SUB
10302393	Not Issued	094	11/22/2002	METHOD FOR FORMING ULTRA LOW K FILMS USING ELECTRON BEAM	YIM, KANG SUB
10376088	Not Issued	094	02/27/2003	ULTRA LOW K PLASMA CVD NANOTUBE/SPIN-ON DIELECTRICS WITH IMPROVED PROPERTIES FOR ADVANCED NANO-ELECTRONIC DEVICE FABRICATION	YIM, KANG SUB
10773060	Not Issued	030	02/04/2004	ULTRA LOW DIELECTRIC MATERIALS BASED ON HYBRID SYSTEM OF LINEAR SILICON PRECURSOR AND ORGANIC POROGEN BY PLASMA-ENHANCED CHEMICAL VAPOR DEPOSITION (PECVD)	YIM, KANG SUB
10873811	Not Issued	030	06/21/2004	HERMETIC CAP LAYERS FORMED ON LOW-K FILMS BY PLASMA ENHANCED CHEMICAL VAPOR DEPOSITION	YIM, KANG SUB
11021319	Not	020	12/22/2004	LOW DIELECTRIC (LOW K)	YIM, KANG SUB

				THE K VALUE IN SIOC LAYER DEPOSITED BY CHEMICAL VAPOR DEPOSITION	
10645675	Not Issued	092	08/20/2003	METHODS OF REDUCING PLASMA-INDUCED DAMAGE FOR ADVANCED PLASMA CVD DIELECTRICS	XIA, LI-QUN
10655276	Not Issued	041	09/03/2003	CLUSTER TOOL FOR E-BEAM TREATED FILMS	XIA, LI-QUN
10718887	Not Issued	030	11/21/2003	METHOD OF ELIMINATING PHOTORESIST POISONING IN DAMASCENE APPLICATIONS	XIA, LI-QUN
10745344	Not Issued	030	12/22/2003	METHOD OF FORMING A LOW-K DUAL DAMASCENE INTERCONNECT STRUCTURE	XIA, LI-QUN
10761122	Not Issued	030	01/20/2004	SOLVENT FREE PHOTORESIST STRIP AND RESIDUE REMOVAL PROCESSING FOR POST ETCHING OF LOW-K FILMS	XIA, LI-QUN
10773060	Not Issued	030	02/04/2004	ULTRA LOW DIELECTRIC MATERIALS BASED ON HYBRID SYSTEM OF LINEAR SILICON PRECURSOR AND ORGANIC POROGEN BY PLASMA-ENHANCED CHEMICAL VAPOR DEPOSITION (PECVD)	XIA, LI-QUN
10783316	Not Issued	030	02/20/2004	METHODS AND APPARATUSES PROMOTING ADHESION OF DIELECTRIC BARRIER FILM TO COPPER	XIA, LI-QUN
10789209	Not Issued	041	02/27/2004	METHOD OF DECREASING THE K VALUE IN SIOC LAYER DEPOSITED BY CHEMICAL VAPOR DEPOSITION	XIA, LI-QUN
10801190	Not Issued	030	03/15/2004	ADHESION IMPROVEMENT FOR LOW K DIELECTRICS	XIA, LI-QUN
10816606	Not Issued	030	04/02/2004	OXIDE-LIKE SEASONING FOR DIELECTRIC LOW K FILMS	XIA, LI-QUN
10828023	Not Issued	030	04/19/2004	ADHESION IMPROVEMENT FOR LOW K DIELECTRICS TO CONDUCTIVE MATERIALS	XIA, LI-QUN
10828441	Not Issued	041	04/20/2004	METHOD OF DEPOSITING LOW K BARRIER LAYERS	XIA, LI-QUN
10840754	Not	030	05/06/2004	IN-SITU OXIDE CAPPING	XIA, LI-QUN

	Issued			AFTER CVD LOW K DEPOSITION	
<u>10875668</u>	Not Issued	071	06/23/2004	USE OF CYCLIC ^{SILOXANES} FOR HARDNESS IMPROVEMENT	XIA, LI-QUN
<u>10888110</u>	Not Issued	020	07/09/2004	BI-LAYER APPROACH FOR A HERMETIC LOW DIELECTRIC CONSTANT LAYER FOR BARRIER APPLICATIONS	XIA, LI-QUN
<u>10894872</u>	Not Issued	030	07/20/2004	METHOD OF DEPOSITING DIELECTRIC FILMS	XIA, LI-QUN
<u>10929884</u>	Not Issued	030	08/30/2004	ADHESION IMPROVEMENT FOR LOW K DIELECTRICS TO CONDUCTIVE MATERIALS	XIA, LI-QUN

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Inventor Name Search Result

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Last Name = XIA

First Name = LI-QUN

Application#	Patent#	Status	Date Filed	Title	Inventor Name
<u>10931609</u>	Not Issued	030	09/01/2004	METHOD TO DEPOSIT FUNCTIONALLY GRADED DIELECTRIC FILMS VIA CHEMICAL VAPOR DEPOSITION USING VISCOUS PRECURSORS	XIA, LI-QUN
<u>10939748</u>	Not Issued	030	09/13/2004	METHOD OF IMPROVING STABILITY IN LOW K BARRIER LAYERS	XIA, LI-QUN
<u>10981430</u>	Not Issued	030	11/03/2004	HIGH-POWER DIELECTRIC SEASONING FOR STABLE WAFER-TO-WAFER THICKNESS UNIFORMITY OF DIELECTRIC CVD FILMS	XIA, LI-QUN
<u>10990251</u>	Not Issued	030	11/15/2004	POST-DEPOSITION TREATMENT TO ENHANCE PROPERTIES OF SI-O-C LOW K FILMS	XIA, LI-QUN
<u>11021319</u>	Not Issued	020	12/22/2004	LOW DIELECTRIC (LOW K) BARRIER FILMS WITH OXYGEN DOPING BY PLASMA-ENHANCED CHEMICAL VAPOR DEPOSITION (PECVD)	XIA, LI-QUN
<u>11032859</u>	Not Issued	020	01/10/2005	METHOD FOR PRODUCING GATE STACK SIDEWALL SPACERS	XIA, LI-QUN
<u>11045650</u>	Not Issued	020	01/28/2005	METHODS AND APPARATUS FOR E-BEAM TREATMENT USED TO FABRICATE INTEGRATED CIRCUIT DEVICES	XIA, LI-QUN
<u>11047785</u>	Not Issued	019	02/01/2005	MULTI STEP EBEAM PROCESS FOR MODIFYING DIELECTRIC	XIA, LI-QUN

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				MATERIALS	
<u>60328018</u>	Not Issued	159	10/09/2001	METHOD OF DEPOSITING LOW K BARRIER LAYERS	XIA, LI-QUN
<u>60340615</u>	Not Issued	159	12/14/2001	METHOD OF DEPOSITING DIELECTRIC MATERIALS IN DAMASCENE APPLICATIONS	XIA, LI-QUN
<u>60378799</u>	Not Issued	159	05/08/2002	METHODS AND APPARATUS FOR E-BEAM TREATMENT USED TO FABRICATE INTEGRATED CIRCUIT DEVICES	XIA, LI-QUN
<u>60397184</u>	Not Issued	159	07/19/2002	LOW K BARRIER FOR COPPER DAMASCENE APPLICATIONS	XIA, LI-QUN
<u>60437472</u>	Not Issued	159	12/31/2002	METHOD OF FORMING A LOW-K DUAL DAMASCENE INTERCONNECT STRUCTURE	XIA, LI-QUN
<u>60558366</u>	Not Issued	020	03/31/2004	MULTI-STAGE CURING OF LOW K NANO-POROUS FILMS	XIA, LI-QUN
<u>60604316</u>	Not Issued	020	08/24/2004	LOW TEMPERATURE PROCESS TO PRODUCE LOW-K DIELECTRICS WITH LOW STRESS BY PLASMA-ENHANCED CHEMICAL VAPOR DEPOSITION (PECVD)	XIA, LI-QUN
<u>60605067</u>	Not Issued	020	08/27/2004	METHOD TO REDUCE PLASMA DAMAGE DURING CLEANING OF SEMICONDUCTOR WAFER PROCESSING CHAMBER	XIA, LI-QUN
<u>60628600</u>	Not Issued	020	11/16/2004	DEPOSITION AND TREATMENT OF TENSILE AND COMPRESSIVE STRESSED LAYERS	XIA, LI-QUN

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Inventor Name Search Result

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Last Name = HOLLAR

First Name = ERIC

Application#	Patent#	Status	Date Filed	Title	Inventor Name
<u>10302393</u>	Not Issued	094	11/22/2002	METHOD FOR FORMING ULTRA LOW K FILMS USING ELECTRON BEAM	HOLLAR, ERIC
<u>10773060</u>	Not Issued	030	02/04/2004	ULTRA LOW DIELECTRIC MATERIALS BASED ON HYBRID SYSTEM OF LINEAR SILICON PRECURSOR AND ORGANIC POROGEN BY PLASMA-ENHANCED CHEMICAL VAPOR DEPOSITION (PECVD)	HOLLAR, ERIC P.

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